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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Johannes Kaeppeler, *et al.*
Serial No. 10/685,233	Filing Date: October 14, 2003
Title of Application:	Method For Depositing Especially Crystalline Layers From The Gas Phase Onto Especially Crystalline Substrates
Confirmation No. 4633	Art Unit: 1762
Examiner	

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents and papers enclosed).

U.S. Patent Documents				
Exam. Initials	Class/ Subclass.	Document No.	Date	Name
	118/48	3,690,290	9/1972	Jarvela et al.
	117/84	5,660,626	8/1997	Sato et al.
	438/478	6,080,642	6/2000	Van Geelen et al.
	117/90	6,086,673	7/2000	Molnar

EWC
9-14-06

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March 4, 2004

Gregory D. Veriuto